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Atty. Docket No.: AB-1350 US

December 31, 2003

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Enclosed herewith for filing is a patent application, as follows:

Inventor:

LEE, Ho

Title:

CHEMICAL VAPOR DEPOSITION APPARATUS

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 $\frac{X}{X}$   $\frac{4}{2}$   $\frac{1}{2}$   $\frac{2}{2}$   $\frac{1}{1}$ 

This Transmittal Letter (in duplicate) page(s) Specification and 1 page(s) Title Page (not including claims)

page(s) Claims

page Abstract

sheet(s) of Drawings (consisting of Figs. 1, 2, and 3)

page(s) Declaration for Patent Application and Power of Attorney

page(s) Change of Correspondence Address

Number			Number					Basic Fee
<u>Filed</u>			Extra		Rate		\$	<u>770.00</u>
9	-20	=	0	X	\$18.00	=	\$	0.00
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2	-3	=	0	X	\$86.00	=	\$	0.00
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EXPRESS MAIL LABEL NO:

EV 302 216 405 US

Respectfully submitted,

David W. Heid Attorney for Applicant

Reg. No. 25,875

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

LEE, Ho

Assignee:

Samsung Electronics Co., Ltd.

Title:

CHEMICAL VAPOR DEPOSITION APPARATUS

Application No.:

Unknown

Filing Date:

Herewith

Examiner:

Unknown

Group Art Unit:

Unknown

Docket No.:

AB-1350 US

San Jose, California December 31, 2003

Mail Stop Patent Application COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

## **CHANGE OF CORRESPONDENCE ADDRESS**

Dear Sir:

Pursuant to 37 C.F.R. § 1.33(a)(2), the undersigned principal attorney of record hereby requests that the correspondence address for the above-referenced patent application be changed to:

David W. Heid MacPherson Kwok Chen & Heid LLP 1762 Technology Drive, Suite 226 San Jose, CA 95110

The daytime telephone number of the undersigned Attorney for Applicant is (408) 392-9250. The Examiner is requested to telephone the undersigned Attorney for Applicant, if the Examiner has any question regarding the above.

**EXPRESS MAIL LABEL NO.:** 

EV 302 216 405 US

Respectfully submitted,

David W. Heid

Attorney for Applicant

Reg. No. 25,875

LAW OFFICES OF MacPherson, Kwok, Chen & Heid LLP

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